

**Notice of References Cited**

Application/Control No.

10/654,178

Applicant(s)/Patent Under  
Reexamination  
KANEHIRA ET AL.

Examiner

Michael Peffley

Art Unit

3739

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,679,882	01-2004	Kornerup, Niels	606/51
*	B	US-6,086,586	07-2000	Hooven, Michael D.	606/50
*	C	US-6,174,309	01-2001	Wrublewski et al.	606/45
*	D	US-6,113,598	09-2000	Baker, James A.	606/51
*	E	US-6,273,887	08-2001	Yamauchi et al.	606/48
*	F	US-5,702,390	12-1997	Austin et al.	606/48
*	G	US-5,151,102	09-1992	Kamiyama et al.	606/51
*	H	US-5,908,420	06-1999	Parins et al.	606/51
*	I	US-5,458,598	10-1995	Feinberg et al.	606/52
*	J	US-6,096,037	08-2000	Mulier et al.	606/49
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
*	N	2000-5188	01-2000	JP		
*	O	WO 98/38935	09-1998	WO	Treat et al	
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
*	U	Office action of 11/8/05 issued in counterpart Japanese application with English translation
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.